



**ELECTRONIC COPY**

LG791620703  
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April 18, 2026

IGI Report Number **LG791620703**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **OVAL BRILLIANT**

Measurements **9.99 X 7.16 X 4.49 MM**

**GRADING RESULTS**

Carat Weight **2.06 CARATS**

Color Grade **D**

Clarity Grade **VVS 2**

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**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**

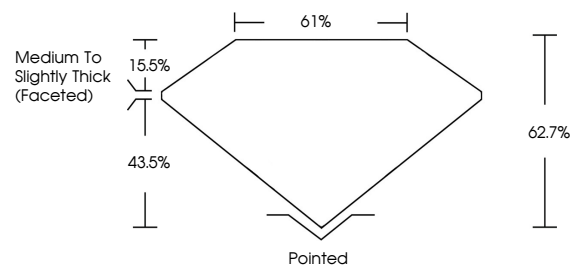
Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG791620703**

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

**PROPORTIONS**



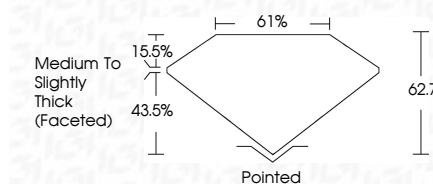
Sample Image Used

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

| FL       | IF                  | VS <sup>1-2</sup>           | VS <sup>1-2</sup>      | SI <sup>1-2</sup> | I <sup>1-3</sup> |
|----------|---------------------|-----------------------------|------------------------|-------------------|------------------|
| Flawless | Internally Flawless | Very Very Slightly Included | Very Slightly Included | Slightly Included | Included         |



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**IGI**



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IGI Report No LG791620703  
OVAL BRILLIANT  
2.06 CARATS  
D  
9.99 X 7.16 X 4.49 MM  
Carat Weight  
Color Grade  
Clarity Grade  
Depth  
Table  
Girdle  
Medium to Slightly Thick (Faceted)  
Culet  
Pointed  
Polish  
EXCELLENT  
Symmetry  
EXCELLENT  
Fluorescence  
NONE  
Inscription(s)  
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